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Dynamic control of heat flow using a spin-chain ladder cuprate film and an ionic liquid

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Dynamic control of heat flow for applications in thermal management has attracted much interest in fields such as electronics and thermal engineering. Spin-chain ladder cuprates are promising materials to realize dynamic control of heat flow, since their magnon thermal conductivity is sensitive to the hole density in the spin ladders, which can be dynamically controlled by an external field. Here, we demonstrate the electric control of heat flow using a polycrystalline cuprate film and an ionic liquid. The results showed that a voltage application to the interface causes imperfectly recoverable decreases in both the thermal conductance of the film and the peak due to magnons in the Raman spectra. This result may be attributed to an increase in the hole density in the spin ladders. This report highlights that magnon thermal conduction has potential for the development of advanced thermal management applications.

Recently, dynamic control of heat flow, such as via thermal conductivity control using field-effect changes in material properties^{1–4} and the spin Seebeck effect^{5,6}, has attracted much interest and has been demonstrated. These control methods have great potential for advanced thermal management, including active heat dissipation, storage, and switching, as they provide stability in highly integrated electronic devices and enable effective reuse of waste heat; moreover, these methods allow temporal-spatial and precise control of temperature in devices and materials whose performance may decrease due to temperature perturbation³.

Spin-chain ladder cuprates such as $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ could be promising materials to achieve dynamic control of heat flow, since they possess unique thermal conduction due to magnons^{7–10} (for the structural property details, see the reviews by Hess⁷ and Vuletić et al.¹¹). Briefly, $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$, which possesses the highest magnon thermal conductivity at room temperature of these types of cuprates, consists of CuO_2 , La/Ca , and Cu_2O_3 layers stacked towards the b -axis (Fig. 1a); among them, the remarkable structure is the Cu_2O_3 layer composed of corner- and edge-sharing CuO_4 squares (Fig. 1a), in which the $S = 1/2$ spins of Cu^{2+} form spin ladders¹¹. In the ladders, magnons, corresponding to excitations of the singlet state of the paired electron spins to the triplet state, act as heat carriers similar to phonons and conduction electrons along the ladders, i.e., towards the c -axis in Fig. 1a, yielding high anisotropic thermal conductivity⁷. Notably, the magnon thermal conductivity is known to be sensitive to the hole density in the spin ladders⁷. For example, $\text{Sr}_{14}\text{Cu}_{24}\text{O}_{41}$ and $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ have the same spin ladder structure (Fig. 1a), but their magnon thermal conductivity at room temperature, with values of ~ 10 and ~ 90 $\text{W}/(\text{m K})^7$, respectively, differ by nearly an order of magnitude. This difference is attributable to the difference in the hole density in the spin ladders; that is, while $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ has no holes in the spin ladders, $\text{Sr}_{14}\text{Cu}_{24}\text{O}_{41}$ has self-doped holes (approximately one hole in the spin ladder per formula unit), leading to a decrease in the mean free path of magnons by magnon-hole scattering and resulting in a drastic decrease in the thermal conductivity^{7,11}. These cuprates also possess phonon thermal conductivity, but the value slightly depends on the composition or transfer direction, which is limited to a few $\text{W}/(\text{m K})^7$.

The sensitivity to the hole density is a remarkable feature because dynamic control of the hole density could enable dynamic control of heat flow. Static control by chemical and defect engineering has been widely researched⁷; however, no research focusing on its dynamic controllability has been conducted yet. To demonstrate dynamic control, we prepared multi-layered samples that include an interface between an ionic liquid (IL) widely used for iontronics, N,N -diethyl- N -methyl- N -(2-methoxyethyl)ammonium bis(trifluoromethanesulfonic)imido

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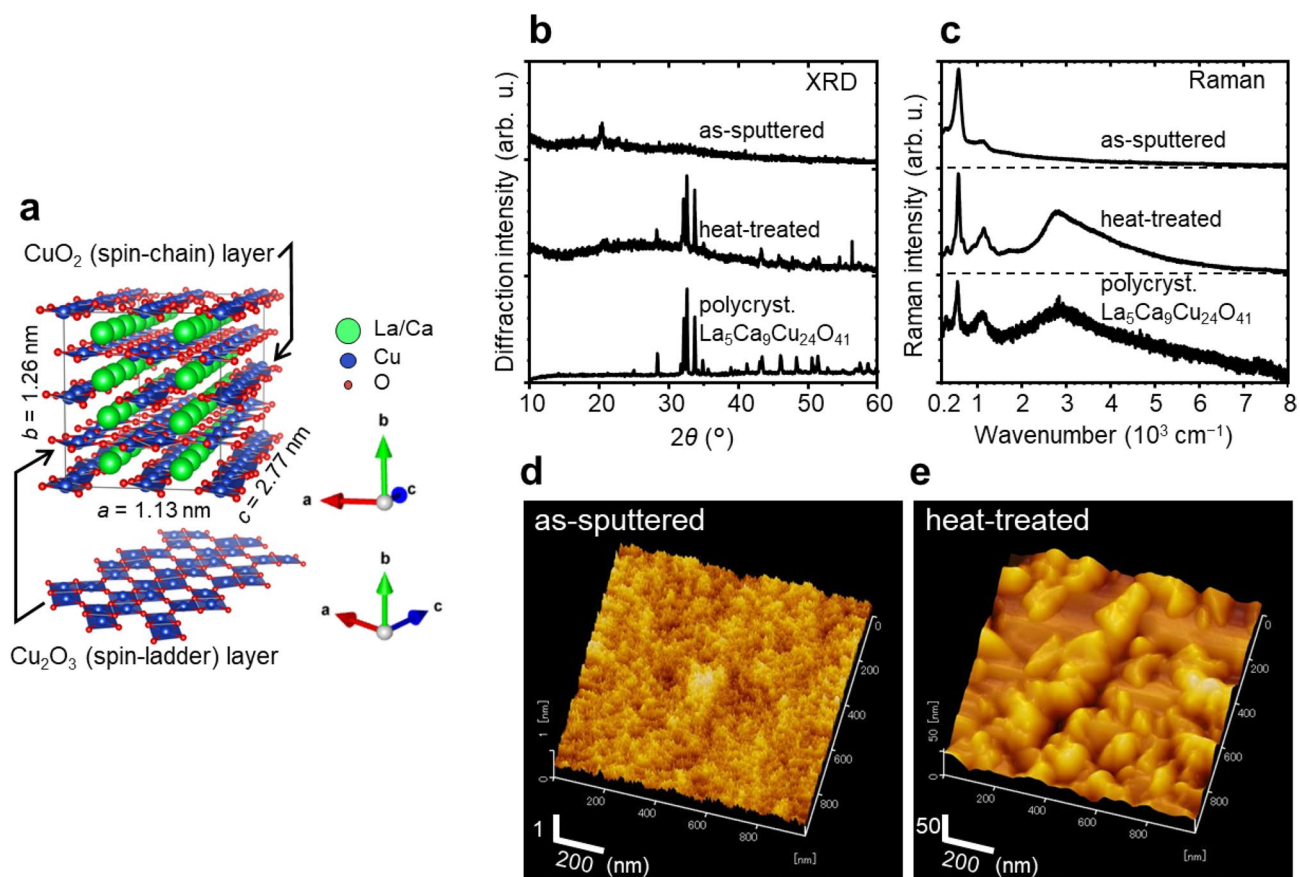


Figure 1. Structural characteristics of the La–Ca–Cu–O film. **(a)** A unit cell of the spin-chain ladder cuprate $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ and a Cu_2O_3 layer with spin ladders. The crystal structures are drawn using VESTA²⁷ and referring to the structural data²⁸. **(b)** XRD patterns and **(c)** Raman spectra of the as-sputtered and heat-treated (400 s at 700 °C) films and polycrystalline $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ synthesized by a solid-state reaction method¹⁷. **(d,e)** Surface morphology obtained by DFM of the as-sputtered and heat-treated films.

(DEME-TFSI)^{12–14}, and a spin-chain ladder system, a La–Ca–Cu–O (LCCO) polycrystalline film, fabricated by radio-frequency (rf) sputtering and post-annealing, where we initially expected that an electric double layer would yield a dense accumulation of holes¹³, resulting in a decrease in thermal conductivity. Clearly, epitaxial or highly oriented films^{15–17} and the single crystal usually grown by the travelling solvent floating zone method^{8,18} should be used to take advantage of their high, anisotropic thermal conduction, but we consider that the use of the polycrystalline film is preferable for increasing the active interfacial area, as described in the Discussion section, and important for practical applications^{19,20}. The results showed that a voltage application causes imperfectly recoverable decreases in the thermal conductance of the film and the peak due to magnons in the Raman spectra, which were evaluated by in situ frequency-domain thermoreflectance (FDTR) and Raman spectroscopy under voltage application, respectively. This result can be interpreted by an increase in the hole density in the spin ladder. This report reveals that the dynamic control of magnon thermal conduction is a promising method for advanced thermal management applications.

Results

Structural investigation of La–Ca–Cu–O films. First, we show the fundamental structural properties of LCCO films. Figure 1b shows the X-ray diffraction (XRD) patterns of the as-sputtered and heat-treated (400 s at 700 °C) LCCO films with a thickness of ~500 nm deposited on the Si substrate. (See the “Methods” section regarding the sample preparation details). The as-sputtered film exhibits two small peaks at $2\theta \sim 20.5^\circ$ and 23.0° , which may be due to amorphous and/or nanocrystalline SiO_2 (tridymite)²¹ formed on the substrate surface. A halo pattern seen in the range of $15\text{--}45^\circ$ indicates that the LCCO film is in an amorphous and/or nanocrystalline state. On the other hand, the heat-treated film shows a halo pattern and sharp peaks corresponding to a powder pattern for the $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ polycrystal¹⁸. The peaks due to SiO_2 become insignificant after the heat treatment.

The Raman spectra of the LCCO films are shown in Fig. 1c. For the as-sputtered film, we see three peaks at ~300, ~580 and ~1,100 cm^{-1} . After the heat treatment, all the peaks become sharp, and a remarkable broad peak centred at ~2,900 cm^{-1} appears. The overall spectrum shows good agreement with that of the powdered $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ polycrystal. Considering that the penetration depth of the probe light with a wavelength of 532 nm for the LCCO film is ~130 nm (Supplementary Fig. S1), these results suggest that the amorphous and/or nanocrystalline LCCO has been crystallized by heat treatment from the surface through a deeper area than

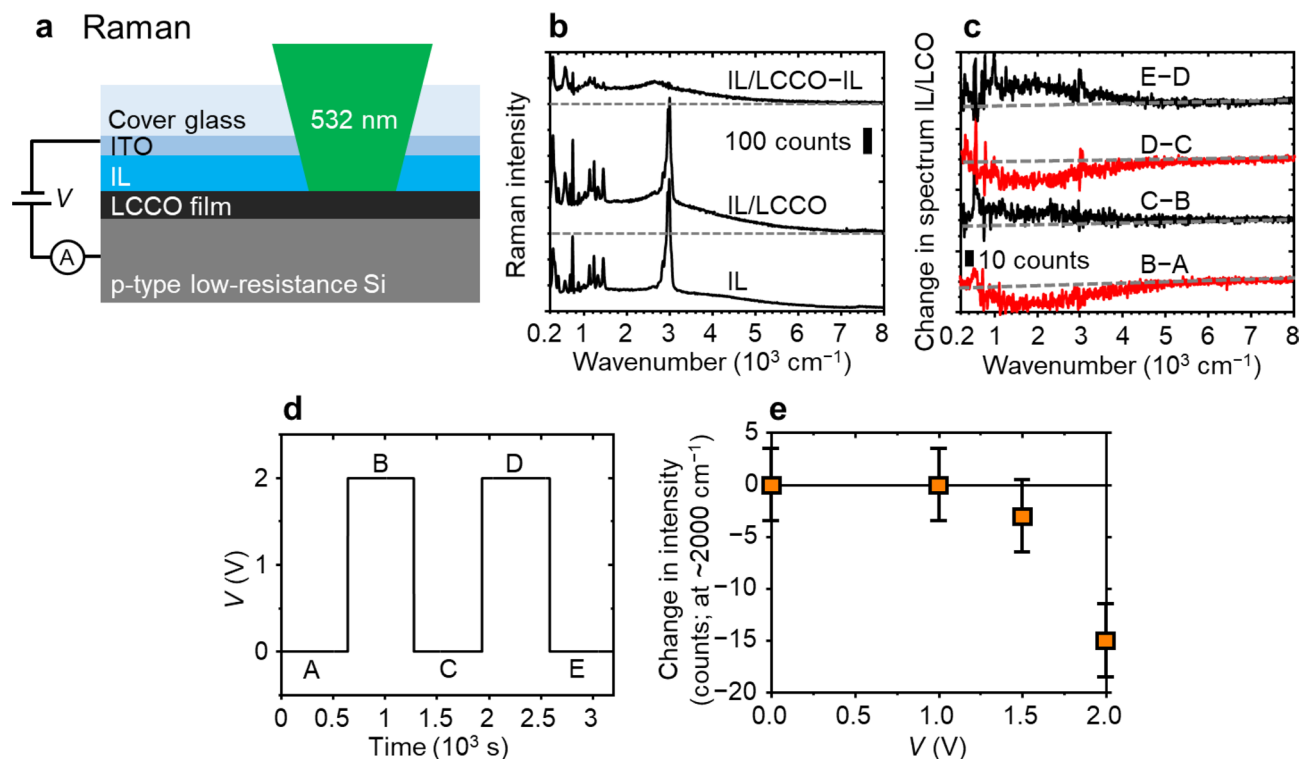


Figure 2. In situ Raman spectroscopy under voltage application. (a) Schematic cross section of the sample, which is drawn neglecting the light refraction. (b) Raman spectra when $V=0$ V and when the laser spot is focused on the half-depth area of the ionic liquid (IL spectrum) and the interface between the ionic liquid and the LCCO film (IL/LCCO spectrum). The IL/LCCO–IL spectrum shows an increase in intensity compared with the IL and IL/LCCO spectra, where IL/LCCO has been normalized so that the peak at $\sim 3,000$ cm^{-1} in DEME⁺³⁰ disappears in the IL/LCCO–IL spectrum. (c) Change in the IL/LCCO–IL spectrum by repetitive voltage application and short-circuiting, as shown in (d). (e) V dependence of the change in intensity at $\sim 2,000$ cm^{-1} .

the penetration depth, which is consistent with the XRD results (Fig. 1b). Here, the peaks at ~ 300 and ~ 580 cm^{-1} can be assigned to A_g modes related to Cu and O, respectively^{22,23}, in the Cu_2O_3 and CuO_2 layers, and the peak at $\sim 1,100$ cm^{-1} is due to two-phonon modes²². The broad peak centred at $2,900$ cm^{-1} , referred to as the two-magnon peak, is unique to materials having antiferromagnetically coupled spins such as $\text{La}_5\text{Ca}_5\text{Cu}_{24}\text{O}_{41}$ ^{24–26}, and its appearance suggests the presence of magnons. Figure 1 also shows the surface morphology observed by dynamic force microscopy (DFM). The as-sputtered film has a smooth surface (Fig. 1d). After the heat treatment, we see plate-like domains with a size of ~ 100 nm, which can correspond to randomly oriented $\text{La}_5\text{Ca}_5\text{Cu}_{24}\text{O}_{41}$ crystals (Fig. 1e).

In situ Raman spectroscopy under voltage application. Figure 2a depicts a schematic cross section of the sample to measure changes in the Raman spectra of the LCCO film by voltage application (see the “Methods” section for the sample preparation). First, we measured spectra by focusing the laser spot on the half-depth area of the ionic liquid and the interface between the ionic liquid and the LCCO film using the setup with $V=0$ (denoted as IL and IL/LCCO in Fig. 2b, respectively). For both spectra, sharp peaks originated from TFSI^- ($<2,000$ cm^{-1}) and DEME^+ ($\sim 3,000$ cm^{-1} ; C–H stretching)^{14,29,30}. The spectrum denoted as IL/LCCO–IL shows an increase in intensity compared with the IL and IL/LCCO spectra, where the IL/LCCO spectrum has been normalized so that the peak at $\sim 3,000$ cm^{-1} due to DEME^+ ³⁰ disappears in the IL/LCCO–IL spectrum. In this spectrum, we clearly see the three peaks at ~ 580 , $\sim 1,100$, and $\sim 2,900$ cm^{-1} , corresponding to those of the heat-treated LCCO film (Fig. 1c), which means that the IL/LCCO spectrum includes information on the LCCO film. (However, the peaks due to TFSI^- remain at a wavenumber of $<2,000$ cm^{-1} , which is mentioned in the “Discussion” section.) Therefore, we examined changes in the IL/LCCO spectrum (Fig. 2c) by voltage application (Fig. 2d). In Fig. 2c, we see that the broad band centred at $\sim 2,000$ cm^{-1} is reduced by $\sim 20\%$ under a voltage application of $V=2$ V with respect to the intensity at $\sim 2,000$ cm^{-1} in the IL/LCCO–IL spectrum and is recovered by short-circuiting. For the second voltage application and its release (spectra D–C and E–D, respectively), we see the appearance of sharp peaks due to DEME^+ and TFSI^- . Considering that the reduced broad band centred at $\sim 2,000$ cm^{-1} is included in the two-magnon peak region and that the two-magnon peak can be reduced by the presence of holes in the spin ladders^{24,26}, these results suggest that the hole density in the spin ladders is increased by an applied voltage and recovered by short-circuiting. Interestingly, the peak position of the reduced band ($\sim 2,000$ cm^{-1}) was shifted to a lower wavenumber than the original one of the two-magnon peak ($\sim 2,900$ cm^{-1}). This shift may be explained by the presence of two types of magnons and selective disappearance by the voltage

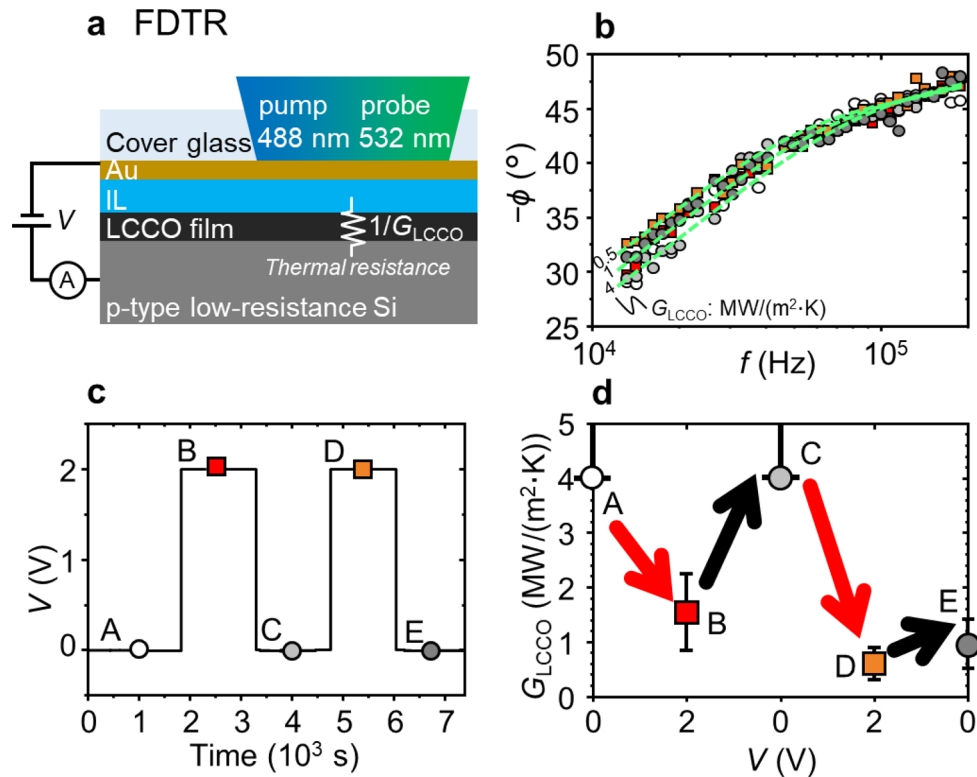


Figure 3. In situ FDTR under voltage application. (a) Schematic cross section of the sample, which is drawn neglecting the light refraction. $1/G_{\text{LCCO}}$ is the thermal resistance between the ionic liquid and the Si substrate; (b) f dependences of $-\phi$ and its response to voltage application shown in (c), where the symbols correspond to those in (c). In (b), the dashed lines are the simulated curves of the analytical solution for $G_{\text{LCCO}} = 0.5, 1,$ and $4 \text{ MW}/(\text{m}^2 \text{ K})$. (d) Change in G_{LCCO} by voltage application. The circles for A and C denote the lower limits of G_{LCCO} .

application: According to a theoretical analysis for spin-ladder cuprates³¹, spectral density of two-magnon state depend on the coupling direction of spins, i.e., along rungs and legs in the spin ladders, and the coupling along rungs yields a spectrum wide-based to a lower wavenumber compared to one along legs³¹. On the basis of this analysis, we consider that the holes in the spin ladders preferentially reduce the spectral density of two-magnon state derived from the coupling along rungs, which may be caused by magnon-hole coupling as is suggested by Sugai and Suzuki²⁴, leading to the ununiform decrease of the two-magnon peak. As shown in Fig. 2e, the change in intensity at $\sim 2,000 \text{ cm}^{-1}$ is remarkably reduced when V exceeds $\sim 1.5 \text{ V}$.

In situ FDTR under voltage application. We performed FDTR measurements under voltage application using the setup in Fig. 3a (see the “Methods” section for the measurement and analysis details). Figure 3b shows the phase lag $-\phi$ of the probe light with respect to the pump light as a function of the modulation frequency f of the pump light and its response to voltage application (Fig. 3c), where the symbols correspond to those in Fig. 3c. The response to the voltage application seems negligible at $f \sim 2 \times 10^5 \text{ Hz}$ and increases with decreasing f . For the analytical fitting of the phase lag data for A (the initial state), four undetermined parameters exist: the interfacial thermal conductance between the cover glass and the Au film ($G_{\text{g}/\text{Au}}$) and that between the Au film and the ionic liquid ($G_{\text{Au}/\text{IL}}$), the thickness of the ionic liquid (d_{IL}), and thermal conductance between the ionic liquid and the Si substrate (G_{LCCO}) (the other parameter settings for the fitting are listed in Supplementary Table S1). The undetermined parameters were determined as follows. First, $G_{\text{g}/\text{Au}}$ was determined to be $\sim 50 \text{ MW}/(\text{m}^2 \text{ K})$ using data at $f > 10^5 \text{ Hz}$, where the value seems plausible, referring to a previous report³². Then, $G_{\text{Au}/\text{IL}}$ was fixed at $50 \text{ MW}/(\text{m}^2 \text{ K})$ because $G_{\text{Au}/\text{IL}}$ is presumed to be $> 10 \text{ MW}/(\text{m}^2 \text{ K})$ ^{33,34}, and we found that the contribution of $G_{\text{Au}/\text{IL}}$ to the phase lag at $f \sim 10^4\text{--}10^5 \text{ Hz}$ is negligible when $G_{\text{Au}/\text{IL}} > 10 \text{ MW}/(\text{m}^2 \text{ K})$. Finally, d_{IL} and G_{LCCO} for A were determined to be $\sim 700 \text{ nm}$ and $\gtrsim 4 \text{ MW}/(\text{m}^2 \text{ K})$, respectively, by analytical fitting. Under this condition, the phase lag is sensitive to a G_{LCCO} value less than $\sim 4 \text{ MW}/(\text{m}^2 \text{ K})$ in the f range of $10^4\text{--}10^5 \text{ Hz}$, as shown by the dashed lines in Fig. 3b. This sensitivity is reasonable because the penetration depth d_p of the temperature wave for the f range is estimated as $0.5\text{--}1.6 \mu\text{m}$, using the thermal diffusivity D of the ionic liquid of $\sim 8 \times 10^{-8} \text{ m}^2/\text{s}$ ³⁵ and the equation $d_p = \sqrt{\frac{D}{\pi f}}$ ³⁶, and the depth range includes the range between the ionic liquid and the Si substrate.

This fact enables estimation of G_{LCCO} by the analytical fitting of B–E in Fig. 3b. Figure 3d shows the change in G_{LCCO} by repetitive voltage application and short-circuiting (Fig. 3c). The initial application (A) causes a decrease

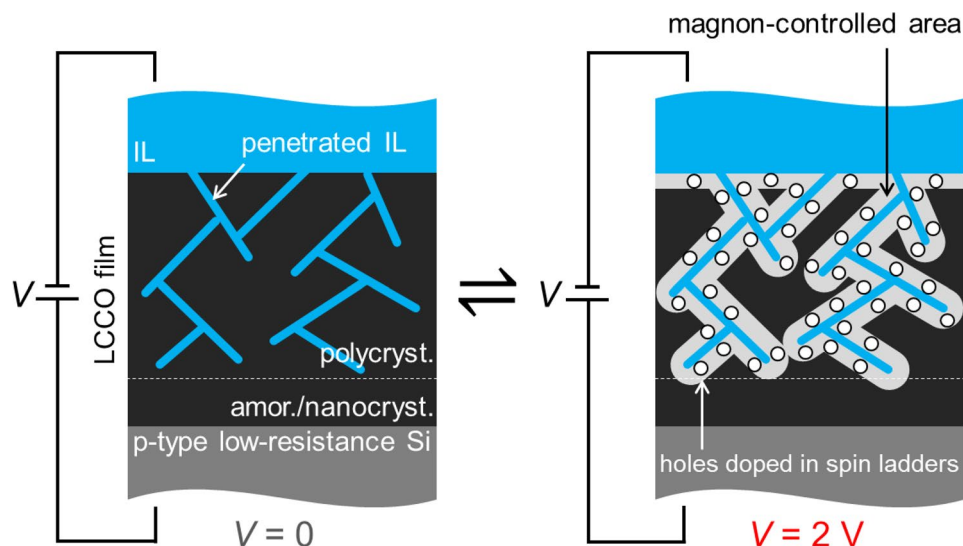


Figure 4. Schematic cross section of the LCCO film with $V=0$ and 2 V .

by at least 40%, which is recovered by the subsequent short-circuiting (B). The subsequent voltage application (C) gives rise to a decrease of one order of magnitude in G (D) that seems to be imperfectly recovered (E).

Discussion

Using the LCCO polycrystalline film and an ionic liquid, we demonstrated that the two-magnon peak in Raman spectra, supporting the presence of magnons, which are the major heat carriers, and the thermal conductance of the film can be dynamically controlled by voltage application (Figs. 2c, 3d). To explain these phenomena, we propose a tentative structural and response model as follows.

Figure 4 ($V=0$) shows a schematic cross section of the sample when $V=0$ focused on the LCCO film, in which we infer that (a) the amorphous and/or nanocrystalline LCCO layer with a thickness of $\sim 100\text{ nm}$ remains on the Si substrate, (b) cracks formed through the domain boundaries exist in the polycrystalline LCCO layer before application of the ionic liquid, and (c) TFSI⁻ in the applied ionic liquid preferentially penetrates into the polycrystalline layer through the cracks, meaning that a complicated series-parallel combination heat circuit consisted of the LCCO domains and the ionic liquid is formed. For (a), the XRD (Fig. 1b) and transmission electron microscopy (TEM) (Supplementary Fig. S2) results support the presence of the layer. For (b), the randomly oriented crystallization (Fig. 1b) of $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ with an anisotropic structure (Fig. 1a) can cause volumetric strain, resulting in cracks. The cleavage at the surface seen in Fig. 2e may support this assumption. Finally, (c) is deduced from the Raman spectroscopy result, i.e., the peaks due to TFSI⁻ remain in the LCCO/IL–IL spectrum, whose origin is unclear, but the p-type conductivity of $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ may be involved.

The recoverable dynamic changes by voltage application can be qualitatively interpreted as follows: Considering the transient current during the short-circuiting process after the voltage application to the sample (Supplementary Fig. S3) and referring to the capacitance of the DEME-TFSI/semiconductor interface^{12–14,37}, the charged hole density n_A is estimated to be 10^{13} – 10^{14} cm^{-2} at most. Here, we need a hole density of approximately one hole in the spin ladder per formula unit at least to change the two-magnon peak and the magnon thermal conductivity of $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$, as described in the Introduction section, so that the volumetric number density n_V is obtained as $\sim 1 \times 10^{21}\text{ cm}^{-3}$ considering that the unit cell (Fig. 1a) consists of four formula units²⁸. Thus, the fractional volume with the reduced magnon thermal conductivity, $(n_A/n_V)/d_{\text{LCCO}}$, is evaluated to be $\sim 0.2\%$, where d_{LCCO} is the thickness of the polycrystalline layer. However, this value seems significantly small to change the two-magnon peak by $\sim 20\%$ (Fig. 2c) and the thermal conductance of the LCCO film by $\sim 40\%$ (Fig. 3d). Therefore, there is a possibility that different factors affect the magnons in the whole film. One of the possible factors is the presence of holes hidden in the CuO_2 (spin-chain) layer (Fig. 1a). That is, $\text{La}_5\text{Ca}_9\text{Cu}_{24}\text{O}_{41}$ also possesses holes in the CuO_2 layers per formula unit (corresponding to $\sim 1 \times 10^{21}\text{ cm}^{-3}$) but not in the Cu_2O_3 (spin-ladder) layer¹¹. In the ground state, the holes in the CuO_2 layers do not disturb the magnons, but under the voltage application, we assume that they are excited to the spin ladders by the electrostatic force with the preferentially penetrated TFSI⁻. The threshold voltage of $\sim 1.5\text{ V}$ in Fig. 2e may support this assumption, because this value nearly corresponds to a difference in Madelung energy between oxygens of the Cu_2O_3 layers and the CuO_2 layers, 1–2 eV, where the oxygens of the CuO_2 layer has the lower energy, leading to the preferable presence in the CuO_2 layers of the holes in the ground state³⁸. If the $\sim 10\text{-nm}$ thick areas of the LCCO domains with a size of $\sim 100\text{ nm}$ surrounded by the ionic liquid are controllable, the volume fraction of the controlled area is estimated to be $\sim 30\%$, which is comparable to the changes in the two-magnon peak and the thermal conductance, although it is difficult to validate the thickness of $\sim 10\text{ nm}$. The significant decrease in G_{LCCO} by the second application of voltage and its imperfect recovery (D and E in Fig. 3d, respectively) may be related to an overpenetration of the ionic liquid with the low thermal conductivity, as indicated in Fig. 2c, and a resultant irreversible structural change. The origins

of the complicated spectral change at $< 1,000 \text{ cm}^{-1}$ in Fig. 2c have been unclear, but irreversible changes in the quantity of penetrated TFSI⁻ and the phonon mode by hole doping³⁹ may be dominant factors.

In summary, we demonstrate the electric control of the two-magnon peak and the thermal conductance of the LCCO film using the ionic liquid. These change amounts were found to be significantly higher than expected from the density of the charged holes. Then, we propose a model in which the ionic liquid penetrates through the cracks formed through the domain boundaries, and the magnons are dynamically controlled throughout the film, which may be due to the excitation of holes in the CuO₂ (spin-chain) layers to the Cu₂O₃ (spin-ladder) layers. We have presented no evidence of the magnon transport, and the results of the Raman spectroscopy just suggest the presence of the magnons and its change, not including information on changes in their mean free path or anisotropy. To elucidate it, we need to investigate the dynamic control using single crystals and measure their life time. Although obtaining a quantitative understanding and achieving high reversibility will be future work, this report reveals that spin-chain ladder cuprates have potential for the development of advanced thermal management applications.

Methods

Sample preparation and fundamental characterization. The LCCO films were deposited on p-type low-resistance (001) Si substrates working as a bottom electrode by using a conventional rf magnetron sputtering system (EB1100, Canon Anelva). The deposition was carried out for 50 min in pure Ar gas with a pressure of 0.5 Pa without substrate heating. The sputtering target was sintered polycrystalline La₅Ca₉Cu₂₄O₄₁ (Toshima Manufacturing Co., Ltd.) that was synthesized by a solid-state reaction method following a previous report¹⁷. The deposited film was heat-treated at 700 °C for 400 s for crystallization in ambient air by using an electric furnace with a heating rate of 10 °C/min and with slow cooling in the furnace. The heat-treated film was confirmed to be ~ 500-nm-thick and a p-type semiconductor by means of the Hall effect measurement. The thicknesses of all the films except for the ionic liquid and the surface morphology of the LCCO films were obtained by DFM (Nanocute, Hitachi High-Tech Corporation). For the LCCO films before and after heat treatment, the XRD patterns were recorded with a New D8 Advance apparatus (Bruker) using CuK_α radiation and a θ -2 θ configuration. Polycrystalline La₅Ca₉Cu₂₄O₄₁ used as a reference in XRD and Raman spectroscopy was synthesized in the same way as the sputtering target.

For in situ Raman spectroscopy (Fig. 2a), an ionic liquid, DEME-TFSI (Kanto Chemical Co., Inc.), was dropped onto the heat-treated film with 150- μm -thick spacers (polyimide tape) and subsequently covered by a cover glass with a 200-nm-thick ITO film deposited on the bottom surface by rf sputtering. For in situ FDTR, the ionic liquid was coated on the heat-treated film, followed by placing a cover glass with a 100-nm-thick Au film deposited on the bottom surface by DC sputtering. The ITO and Au films work as top electrodes and at the same time as a transparent window for Raman spectroscopy and a transducer for FDTR, respectively. These top electrodes and the conductive Si substrate were connected to a source meter (2450, Keithley) using thermosetting Ag paste and electrical wires, and the voltage and current were recorded. The active electrode area for both measurements was ~ 1.0 cm².

Raman spectroscopy. Raman spectra were obtained using a conventional system (NRS-4500, JASCO) at room temperature, including confocal microscopy with a 20 \times objective lens and an excitation source of a 532-nm laser light. The scattered light was detected with a backscattering configuration with no polarizer, while the light incident to the samples was linearly polarized. For the in situ observation under the voltage application, the intensity was recorded for 300 s after the transient current became nearly stable, which was 200–300 s after voltage switching (see Supplementary Fig. S3), and the same is true for in situ FDTR.

FDTR. FDTR measurements were performed at room temperature with reference to a setup by Regner et al. (Fig. 1a in Ref.⁴⁰). In our study, pump and probe lights with wavelengths of 488 and 532 nm were emitted from a laser-diode module (PhonX+, Omicron) and a diode-pumped solid-state laser module (GLK 32200 TS, LASOS), respectively, in which the pump light was directly sinusoidally modulated with a frequency of f by a function generator (33612A, Keysight Technologies). The phase lag with respect to the pump light, $-\phi$, of the probe light modulated by the sinusoidal heating was detected by using a dual phase lock-in amplifier (LI5660, NF Corporation). The parameters used for the analysis are listed in Supplementary Table S1, in which the thermal conductivity of the Au film was evaluated with the Wiedemann–Franz law⁴¹ and the laser beam radius was measured by the knife-edge method⁴².

Generally, the phase lag data are fitted via nonlinear least-square algorithms to the analytical solution of the heat equation for the multi-layered structure whose top surface is sinusoidally heated^{36,43}, which we basically followed in this work. However, in our case (Fig. 3a), the transducer, the Au film, is placed under the cover glass, and accordingly, the heat dissipation towards the cover glass is not negligible. Therefore, we modified the heat equation model as follows: first, we separate the total heat flux f_t inflowing to the top surface of the Au film into that towards the cover glass and towards the Si substrate, f_d and f_u , where the subscripts d and u denote downward and upward, respectively, meaning that $f_t = f_d + f_u$. From the same insight as the traditional model^{36,43}, we obtain the relation $\theta_t = (-D_d/C_d)f_d = (-D_u/C_u)f_u$, where C_u and D_u correspond to the elements of the multiplied matrix in Ref.³⁶ and are related to the interfacial thermal conductance between the Au film and the cover glass and the thermal conductivity, specific heat, and thickness of the cover glass. These relations yield $\theta_t = -f_t/[C_d/D_d + C_u/D_u]$, corresponding to the replacement of C/D in the traditional model with $C_d/D_d + C_u/D_u$.

Data availability

The authors declare that the data supporting the findings of this study are available within the article.

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Author contributions

Y.N., N.T. and Y.M. built the experimental system and fabricated and characterized the samples. N.T., T.F., Y.N., Y.M. and Y.T. designed the work. N.T. wrote the manuscript.

Competing interests

The authors declare no competing interests.

Additional information

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